

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

: Confirmation No. 1632

Norio KIMURA et al.

Docket No. 2001-0660A

Serial No. 09/864,208

Group Art Unit 1763

Filed May 25, 2001

Examiner Jeffrie R. Lund

SUBSTRATE POLISHING APPARATUS AND

Mail Stop: RCE

SUBSTRATE POLISHING METHOD

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Petition hereby is made for a one month extension of time to respond to the communication of May 16, 2005.

The fee of \$120.00 is

- (X) submitted herewith.
- () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
- () Small entity status of this application is established by a Small Entity Status Assertion which
 - () is enclosed.
 - () has been previously submitted.

Respectfully submitted,

Norio KIMURA et al.

Nils E. Pedersen

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

09/08/2005 SZEWDIE1 00000018 09864208

02 FC:1251

120.00 OP

Registration No.33,145
Attorney for Applicants

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